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ATTENTION: BOX AFTER FINAL
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1722

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2230

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Kenji HASHIMOTO)

Application No.: 09/503,170)

Filed: February 14, 2000)

For: RESIN ENCAPSULATING)
APPARATUS AND METHOD)
USED IN A MANUFACTURE OF A)
SEMICONDUCTOR DEVICE)

Group Art Unit: 1722

Examiner: R. Davis

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action of January 24, 2003, and pursuant to 37 C.F.R.
§ 1.116, Applicant proposes that this application be amended as follows:

IN THE CLAIMS:

Please amend claims 1 and 8, as follows:

1. (Twice Amended) A resin encapsulating apparatus comprising:
a retaining section which retains a semiconductor device;

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